Docket No.: 060188-0578 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 53080

Shinichi IMAI, et al. : Confirmation Number: 4939

Application No.: 10/619,191 : Group Art Unit: 2125

Filed: July 15, 2003 : Examiner: Maria N. Von Buhr

For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION

APPARATUS

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

REQUEST TO CONSIDER REFERENCES AFTER CLOSE OF PROSECUTION AND BEFORE PAYMENT OF ISSUE FEE

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue there from. Please charge the processing fee under 1.17(p) of \$180.00 to Deposit Account.

10/619,191

CERTIFICATION PARAGRAPH

The undersigned certifies that each item of information contained in this Information

Disclosure Statement was first cited in a communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this Information

Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application

search report or office action and its relevance discussed therein. A copy of the foreign search

report or office action, together with an English language version thereof, is attached for the

Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 500417 and please credit any excess fees to

such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Please recognize our Customer No. 53080

as our correspondence address.

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Facsimile: 202.756.8087 Date: June 14, 2007

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION				ATTY. DOCKET NO. 060188-0578							
					APPLICANT Shinichi IMAI,	APPLICANT Shinichi IMAI, et al.					
(PTO-1449)					FILING DATE July 15, 2003				OUP 25		
			U	.S. PATEN	T DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (# known)		Publication Da MM-DD-YYY		licant of Cited	Pages, Columns, Lines, Whe Relevant Passages or Releva Figures Appear		es or Relevant		
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					or, Title, Date, Pertinent Pages, E		722.5	Daniel III			
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		Notice of Reasons for Rejection dated May 15, 2007									
EXAMINER					DATE CONSIDE	ERED					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

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